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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Achintya K. Bhowmik Et Al.

§ Group Art Unit:

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§ Examiner:

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§ Atty. Dkt. No.: ITL.1099US

§ (P18549)

Serial No.: 10/814,402

Filed: March 31, 2004

For: Single Crystal Electro-Optic
Film On Silicon ImagerCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Applicant submits the references listed on the attached form PTO 1449, copies of which are enclosed. A copy of a communication dated July 15, 2005 from a foreign patent office in a counterpart application is also enclosed. I, the undersigned, hereby certify that each item of information contained in the Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the Information Disclosure Statement. Please apply any charges or credits to Deposit Account No. 20-1504 (ITL.1099US).

Respectfully submitted,

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July 27, 2005

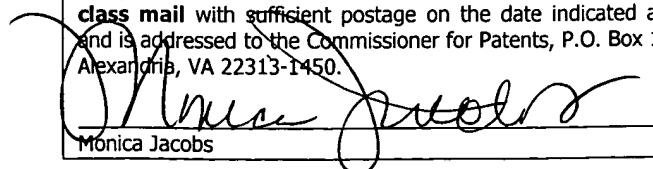
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Monica Jacobs

<p style="text-align: center;">INFORMATION DISCLOSURE CITATION <small>(Use several sheets if necessary)</small></p> <p style="text-align: center;">AUG 01 2005</p>				ATTY DOCKET NO. ITL.1099US (P18549)		SERIAL NO. 10/814,402	
				APPLICANT(S): Achintya K. Bhowmik et al.			
				FILING DATE: March 31, 2004		GROUP ART UNIT:	
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
A.	3,435,445	02/24/1966	W.R. Clendinning et al.				
B.	5,396,362	03/07/1995	Yakymyshyn et al.				
C.	5,943,154	08/24/1999	Nakayama				
D.	6,346,430	02/12/2002	Raj et al.				
E.							
U.S. PATENT APPLICATION PUBLICATIONS							
F.							
G.							
H.							
I.							
J.							
FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO	
K.	EP 0 362 839	04/11/1990	Europe				
L.							
M.							
N.							
O.							
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
P.	R. Kumar et al., <i>Growth and Characterization of 4-dimethylamino-N-methyl-4-stilbazolium tosylate (DAST) Single Crystals</i> , Journal of Crystal Growth, North-Holland Amsterdam, NL, Vol. 250, No. 1-2, March 2003, pgs. 113-117.						
Q.							
R.							
S.							
T.							
EXAMINER				DATE CONSIDERED			
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>							